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JUL 4 - 2006

Examiner:

Group Art Unit:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Chen et al

Serial No.:

10/661,089

........

September 10, 2003

For:

Filed:

METHOD FOR MITIGATING CHEMICAL VAPOR DEPOSITION PHOSPHORUS DOPING OXIDE

SURFACE INDUCED DEFECTS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the Office Action mailed April 3, 2006, Applicants respectfully request that the following amendments be entered in the above-identified patent application:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

Hoang, Quoc Dinh

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